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Substitute for form 1449B/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	10/662,886
Date Submitted: 11/6/03				Filing Date	09/16/2003
(use as many sheets as necessary)				First Named Inventor	Takashi NAGASE
				Group Art Unit	Unassigned
				Examiner Name	Unassigned
				Attorney Docket Number	023312-0109
Sheet	1	of	1		

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			

FOREIGN PATENT DOCUMENTS								
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SA ↓ ✓ SA	A4	R.L. Kubena, et al, A Low Magnification Focused Ion Beam System with 8 nm spot size*, J. Vac. Sci. Technol. B9, 3079-3083 (1991)	Y	
	A5	S. Matsui, et al, High Resolution Focused Ion Beam Lithography, J. Vac. Sci. Technol. B9, 2622-2632 (1991)	Y	
	A6	M.A. Reed, Molecular-Scale Electronics, Proc. IEEE, 87, 652-658 (1999)	Y	
	A7	A. Aviram, et al, Molecular Electronics II, New York Academy of Sciences, New York (2002) – Table of Contents	Y	
	A8	Y. Wada, et al., Prospects and Problems of Single Molecule Information Devices, Jpn. J. Appl. Phys. Part 1, 39, 3835-3849 (2000)	Y	

Examiner Signature	Shamim Ahmed	Date Considered	6/6/05
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				First Named Inventor	Takashi NAGASE
				Group Art Unit	Unassigned
				Examiner Name	Unassigned
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SA	A1	Technical Report of IEICE, Vol. 102, No. 303, 2002, pp. 33-36	Y
SA	A2	Nice, Vol. 2, No. 3, 2002, pp. 3-7	Y
SA	A3	Conference Program of ICNME, Dec. 10-12, 2002, pp. 221-222.	Y

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